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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO. 039262-0156

Applicants: Tadahiro OHMI et al
Title: METHOD OF MANUFACTURING A SEMICONDUCTOR
DEVICE AND METHOD OF ETCHING AN INSULATING
FILM
Appl. No.: 10/588,698
Filing Date: 08/08/2006
Examiner: Caridad Everhart
Art Unit: 2895
Confirmation Number: 9929

REQUEST TO PLACE DOCUMENTS IN PATENT FILE
UNDER 37 C.F.R. § 1.97(i)

MAIL STOP: ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

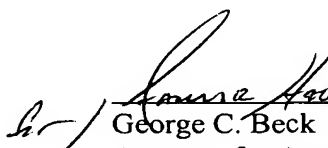
Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56. Applicants request that the listed documents be placed of record in the file of this application.

The listed documents were cited during a search of the corresponding European application, a copy of the European Search Report is enclosed.

Respectfully submitted,

April 13, 2009
Date

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